

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q96773

Takeyoshi KANO, et al.

Appln. No.: 10/594,227

Group Art Unit: 3729

Confirmation No.: 3397

Examiner: Carl J. ARBES

Filed: September 25, 2006

For: METHOD FOR FORMING SURFACE GRAFT, METHOD FOR FORMING CONDUCTIVE FILM, METHOD FOR FORMING METHOD PATTERN, METHOD FOR FORMING MULTILAYER WIRING BOARD, SURFACE GRAFT MATERIAL, AND CONDUCTIVE MATERIAL

RESPONSE UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 18, 2009, please consider the remarks as submitted herewith on the accompanying pages.

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